

about the first edition . . .

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This timely *Second Edition* of a **broadly based** reference furnishes a basic understanding of *each important topic* in vacuum science and technology—concentrating on pumping issues and emphasizing the behavior of vacuum pumps and vacuum systems.

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about the author . . .

MARSHED H. HABLNIAN was Manager of Engineering, Technical Director, Vacuum Products, Varian Associates, Inc., Lexington, Massachusetts, until his recent retirement. The author of more than 80 technical articles on high-vacuum technology, several book chapters on vacuum physics and technology, and a monograph on diffusion pumps, Mr. Hablani is the recipient of the Albert Nerken Award of the American Vacuum Society (1987), the Nat Sugermen Award of the Society of Vacuum Coaters, and an award of the Association of Vacuum Equipment Manufacturers (1989). Internationally renowned for his work in the field, he was invited to present papers at three international vacuum congresses. Mr. Hablani is an honorary member and Fellow of the American Vacuum Society and was an Associate Editor of the *Journal of Vacuum Science and Technology*. He received the B.S. (1955) and M.S. (1957) degrees in mechanical engineering from the Massachusetts Institute of Technology, Cambridge, and he holds 15 U.S. patents.

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